

## Application Data Sh

### Application Information

Application number::

Filing Date::

Application Type::

Subject Matter::

Suggested Classification::

Suggested Group Art Unit::

CD-ROM or CD-R?: No

Title: VARIABLE FLOW DEPOSITION APPARATUS  
AND METHOD IN SEMICONDUCTOR SUBSTRATE PROCESSING

Attorney Docket Number: 5018/ISM/CORE/MCVD

Request for Early Publication?: No

Request for Non-Publication?: No

Suggested Drawing Figure::

Total Drawing Sheets: 4

Small Entity?: No

Petition Included?: No

Secrecy Order in Parent Appl.?: No

### Applicant Information

Applicant Authority Type: Inventor

Primary Citizenship Country: US

Status: Full Capacity

Given Name: Avi

Middle Name::

Family Name: TEPMAN

Name Suffix::

City of Residence: Cupertino

State or Province of Residence: California

Country of Residence: USA

Street of Mailing Address: 21610 Rainbow Drive

City of Mailing Address: Cupertino

## Application Data

State or Province of Mailing Address:: California  
Country of Mailing Address:: USA  
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Applicant Authority Type:: Inventor  
Primary Citizenship Country:: US  
Status:: Full Capacity  
Given Name:: Lawrence  
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Name Suffix::  
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Postal or ZIP Code of Mailing Address:: 95035

## Correspondence Information

Correspondence Customer Number::  
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State or Province of Mailing Address:: California  
Country of Mailing Address:: USA  
Postal or ZIP Code of Mailing Address:: 95052  
Phone number::  
Fax number::  
E-mail address::

**Representative Information**

Representative Designation::	Registration Number::	Representative Name::
Primary	33,217	Donald Verplancken
Associate	28,868	William K. Konrad

**Domestic Priority Information**

Application::	Continuity Type::	Parent Application::	Parent Filing Date::

**Foreign Priority Information****Assignment Information**

Assignee Name:: Applied Materials, Inc.